

Notice of References Cited	Application/Control No. 09/728,193	Applicant(s)/Patent Under Reexamination MORITA, ETSUO	
	Examiner Matthew J. Song	Art Unit 1722	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Chen et al, "Dislocation reduction in GaN thin films via lateral overgrowth from trenches", Applied Physics Letters, Vol 75, Num 14, pg 2062-63 (1999).
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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